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Enabling significant scaling of wordline switch with wordline dependent negative bitline voltage

Abstract

A memory device is provided and includes a memory block that has a plurality of memory cells that are arranged in a plurality of word lines. The memory device also includes a plurality of word line switch transistors that are electrically coupled with the plurality of word lines, where the plurality of word lines are grouped into a plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines. The memory device also includes a bitline biasing circuit for providing a negative biasing voltage to a bitline corresponding to a memory cell of the selected word line during programming of the selected word line and the bitline biasing circuit is configured to set a magnitude of the negative biasing voltage based on which zone of the plurality of zones the selected word line is in.

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Background/Summary

CROSS-REFERENCE TO RELATED APPLICATIONS (1) This application claims the benefit of U.S. Provisional Application No. 63/468,846, filed on May 25, 2023. The entire disclosure of the application referenced above is incorporated herein by reference.

BACKGROUND

1. Field

(1) The present disclosure is related generally to a word line switch design in a memory device.

2. Related Art

(2) Semiconductor memory is widely used in various electronic devices, such as cellular telephones, digital cameras, personal digital assistants, medical electronics, mobile computing devices, servers, solid state drives, non-mobile computing devices and other devices. Semiconductor memory may comprise non-volatile memory or volatile memory. A non-volatile memory allows information to be stored and retained even when the non-volatile memory is not connected to a source of power, e.g., a battery.

(3) NAND memory devices include a chip with a plurality of memory blocks, each of which includes an array of memory cells arranged in a plurality of word lines. Programming the memory cells of a word line to retain data typically occurs in a plurality of program loops, each of which

includes the application of a programming pulse to a control gate of the word line and, optionally, a verify operation to sense the threshold voltages of the memory cells being programmed. Each program loop may also include a pre-charge operation prior to the programming pulse to pre-charge a plurality of channels containing memory cells to be programmed.

SUMMARY

(4) This section provides a general summary of the present disclosure and is not a comprehensive disclosure of its full scope or all of its features and advantages.

(5) An object of the present disclosure is to provide a memory apparatus and a method of operation of the memory apparatus that address and overcome shortcomings described herein.

(6) Accordingly, it is an aspect of the present disclosure to provide a memory device. The memory device comprises: a memory block that includes a plurality of memory cells that are arranged in a plurality of word lines; and a plurality of word line switch transistors that are electrically coupled with the plurality of word lines, where the plurality of word lines are grouped into a plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines. The memory device also comprises programming circuitry being configured to program a selected word line of the plurality of word lines to respective intended data states in a plurality of program loops and a bitline biasing circuit for biasing a bitline corresponding to a memory cell of the selected word line during programming of the selected word line. The bitline biasing circuit operates to provide a negative biasing voltage to the bitline, where the bitline biasing circuit is configured to set a magnitude of the negative biasing voltage based on which zone of the plurality of zones the selected word line is in.

(7) Accordingly, it is an aspect of the present disclosure to provide a method of operating a memory device. The method comprising the steps of programming a selected word line of a plurality of word lines to respective intended data states in a plurality of program loops and biasing a bitline corresponding to a memory cell of the selected word line during programming of the selected word line, where biasing the bitline comprises providing a negative biasing voltage to the bitline and setting a magnitude of the negative biasing voltage based on a zone of a plurality of zones the selected word line is in. The plurality of word lines are grouped into the plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines.

(8) Accordingly, it is an aspect of the present disclosure to provide an apparatus. The apparatus comprises: a means for programming a selected word line of a plurality of word lines to respective intended data states in a plurality of program loops; a means for providing a negative biasing voltage to a bitline corresponding to a memory cell of the selected word line during programming of the selected word line; and a means for setting a magnitude of the negative biasing voltage based on a zone of a plurality of zones the selected word line is in, wherein the plurality of word lines are grouped into the plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines

Description

BRIEF DESCRIPTION OF THE DRAWINGS

(1) A more detailed description is set forth below with reference to example embodiments depicted in the appended figures. Understanding that these figures depict only example embodiments of the disclosure and are, therefore, not to be considered limiting of its scope. The disclosure is described and explained with added specificity and detail through the use of the accompanying drawings in which:

(2) FIG. 1 is a schematic block diagram illustrating a system according to aspects of the disclosure;

(3) FIG. 2A is a schematic block diagram illustrating another system according to aspects of the disclosure;

- (4) FIG. 2B is a schematic block diagram of a controller of the system of FIG. 2A;
- (5) FIG. 3 is a schematic block diagram illustrating a NAND string according to aspects of the disclosure;
- (6) FIG. 4 is a schematic block diagram illustrating a memory array according to aspects of the disclosure;
- (7) FIG. 5 illustrates one embodiment of a top view of a portion of a memory array according to aspects of the disclosure;
- (8) FIG. 6 illustrates one embodiment of a cross-sectional view of a portion of a memory array according to aspects of the disclosure;
- (9) FIG. 7 illustrates a cross-sectional view of a memory array according to aspects of the disclosure;
- (10) FIG. 8 illustrates a word lines driven from one side in accordance with the prior art;
- (11) FIG. 9 illustrates a memory array according to aspects of the disclosure;
- (12) FIG. 10 shows a side cross-sectional view of an example memory die and illustrates a portion of the die in which word line switches reside according to aspects of the disclosure;
- (13) FIG. 11 shows word line switches connected to word lines of a selected block and multiple unselected blocks along with voltages applied to gates of the word line switches for two different schemes according to aspects of the disclosure;
- (14) FIG. 12 shows a top cross-sectional view of a portion of an example memory die illustrating dimensions of word line switches including at least one width according to aspects of the disclosure;
- (15) FIG. 13 is a plot of a switch threshold voltage of the word line switch versus a back bias of the word line switch for different widths of the word line switch according to aspects of the disclosure;
- (16) FIG. 14 is a schematic view of a three-tiered memory hole;
- (17) FIG. 15 is a plot of a plurality of word lines in an example memory block and the associated VPGMmax and Vwlswov voltages;
- (18) FIG. 16 is a schematic view of a plurality of word line switches constructed according to one example embodiment of the present disclosure;
- (19) FIG. 17 is a flow chart illustrating the steps of programming a selected word line according to one example embodiment;
- (20) FIG. 18 is a flow chart illustrating the steps of programming a selected word line according to another example embodiment;
- (21) FIG. 19 is a schematic view of a two-tiered memory hole according to another example embodiment;
- (22) FIG. 20 a flow chart is provided that depicts the steps of programming a selected word line WLn by word line negative bitline implementation according to another example embodiment;
- (23) FIG. 21 depicts a flow chart of a conventional program method with QPW until programming of a final program state without QPW according to another embodiment of the present disclosure; and
- (24) FIG. 22 a flow chart is provided that depicts the steps of programming a selected word line WLn according to another embodiment of the present disclosure.

DESCRIPTION OF THE ENABLING EMBODIMENTS

- (25) As discussed in further detail below, the present disclosure is related generally to a memory device which includes a unique word line switch area that includes a plurality of word line switches that have different widths and also is related to techniques for programming a selected word line using the word line switches of different widths.
- (26) In the following description, details are set forth to provide an understanding of the present disclosure. In some instances, certain circuits, structures and techniques have not been described or shown in detail in order not to obscure the disclosure.
- (27) In general, the present disclosure relates to non-volatile memory apparatuses of the type well-

suited for use in many applications. The non-volatile memory apparatus and associated methods of operation of this disclosure will be described in conjunction with one or more example embodiments. However, the specific example embodiments disclosed are merely provided to describe the inventive concepts, features, advantages and objectives with sufficient clarity to permit those skilled in this art to understand and practice the disclosure. Specifically, the example embodiments are provided so that this disclosure will be thorough, and will fully convey the scope to those who are skilled in the art. Numerous specific details are set forth such as examples of specific components, devices, and methods, to provide a thorough understanding of embodiments of the present disclosure. It will be apparent to those skilled in the art that specific details need not be employed, that example embodiments may be embodied in many different forms and that neither should be construed to limit the scope of the disclosure. In some example embodiments, well-known processes, well-known device structures, and well-known technologies are not described in detail.

(28) In some memory devices or apparatuses, memory cells are joined to one another such as in NAND strings in a block or sub-block. Each NAND string comprises a number of memory cells connected in series between one or more drain-side select gate SG transistors (SGD transistors), on a drain-side of the NAND string which is connected to a bit line, and one or more source-side select gate SG transistors (SGS transistors), on a source-side of the NAND string which is connected to a source line. Further, the memory cells can be arranged with a common control gate line (e.g., word line) which acts a control gate. A set of word lines extends from the source side of a block to the drain side of a block. Memory cells can be connected in other types of strings and in other ways as well.

(29) In a 3D memory structure, the memory cells may be arranged in vertical strings in a stack, where the stack comprises alternating conductive and dielectric layers. The conductive layers act as word lines that are connected to the memory cells. The memory cells can include data memory cells, which are eligible to store user data, and dummy or non-data memory cells, which are ineligible to store user data.

(30) Before programming certain non-volatile memory devices, the memory cells are typically erased. For some devices, the erase operation removes electrons from the floating gate of the memory cell being erased. Alternatively, the erase operation removes electrons from the charge-trapping layer.

(31) Each memory cell may be associated with a data state according to write data in a program command. Based on its data state, a memory cell will either remain in the erased state or be programmed to a programmed data state that is associated with a predetermined range of threshold voltages V_t . For example, in a one bit per cell storage scheme, there are two data states including the erased state and one programmed state, and in a three bit per cell storage scheme, there are eight data states including the erased state and seven programmed states.

(32) During a program operation, the memory cells are programmed according to a word line programming order. For example, the programming may start at the word line at the source side of the block and proceed to the word line at the drain side of the block. In one approach, each word line is completely programmed before programming a next word line. For example, a first word line, WL0, is programmed using one or more programming pulses until the programming is completed. Next, a second word line, WL1, is programmed using one or more programming pulses until the programming is completed, and so forth. A programming pulse may include a set of increasing program voltages VPGM which are applied to the word line in respective program loops or program-verify iterations. Verify operations or stages may be performed after each program voltage to determine whether the memory cells have completed programming to their respective intended data states. When programming is completed for a memory cell, it can be inhibited from further programming while programming continues for other memory cells in subsequent program loops.

(33) A memory device may have word line switches transistors (hereinafter referred to as “WLSWs” or “WLSW” in the singular) coupled to one or more word lines (WLs) from memory blocks of memory cells. As the quantity of word lines in a memory block increases, the quantity of WLSWs associated with that memory block. Thus, a width of a WLSW switch area in a complementary metal-oxide (CMOS) layer of the chip increases as a result.

(34) FIG. 1 is a block diagram of one embodiment of a system **100** comprising non-volatile memory device(s) **118** configured in accordance with an embodiment of the claimed solution. A computing device **104** may comprise non-volatile memory system **102**, a processor **106**, volatile memory **108**, and a communication interface **110**. The processor **106** may comprise one or more central processing units, one or more general-purpose processors, one or more application-specific processors, one or more virtual processors (e.g., the computing device **104** may be a virtual machine operating within a host), one or more processor cores, or the like. The communication interface **110** may comprise one or more network interfaces configured to communicatively couple the computing device **104** and/or non-volatile memory controller **126** to a communication network **114**, such as an Internet Protocol (IP) network, a Storage Area Network (SAN), wireless network, wired network, or the like.

(35) The non-volatile memory device(s) **118**, in various embodiments, may be disposed in one or more different locations relative to the computing device **104**. In one embodiment, the non-volatile memory device(s) **118** comprises one or more non-volatile memory element(s) **122**, such as semiconductor chips, memory die, or packages or other integrated circuit devices disposed on one or more printed circuit boards, storage housings, and/or other mechanical and/or electrical support structures. For example, the non-volatile memory device(s) **118** may comprise one or more direct inline memory module (DIMM) cards, one or more expansion cards and/or daughter cards, a solid-state-drive (SSD) or other hard drive device, and/or may have another memory and/or storage form factor known to those of skill in the art. The non-volatile memory device(s) **118** may be integrated with, and/or mounted on, a motherboard of the computing device **104**, installed in a port and/or slot of the computing device **104**, installed on a different computing device **104** and/or a dedicated storage appliance on the network **114**, in communication with the computing device **104** over an external bus (e.g., an external hard drive), or the like.

(36) The non-volatile memory device(s) **118**, in one embodiment, may be disposed on a memory bus of a processor **106** (e.g., on the same memory bus as the volatile memory **108**, on a different memory bus from the volatile memory **108**, in place of the volatile memory **108**, or the like). In a further embodiment, the non-volatile memory device(s) **118** may be disposed on a peripheral bus of the computing device **104**, such as a peripheral component interconnect express (PCI Express or PCIe) bus, a serial Advanced Technology Attachment (SATA) bus, a parallel Advanced Technology Attachment (PATA) bus, a small computer system interface (SCSI) bus, a FireWire bus, a Fibre Channel connection, a Universal Serial Bus (USB), a PCIe Advanced Switching (PCIe-AS) bus, or the like. In another embodiment, the non-volatile memory device(s) **118** may be disposed on a data network **114**, such as an Ethernet network, an Infiniband network, SCSI RDMA over a network **114**, a storage area network (SAN), a local area network (LAN), a wide area network (WAN) such as the Internet, another wired and/or wireless network **114**, or the like.

(37) The computing device **104** may further comprise a non-transitory, computer readable storage medium **112**. The computer readable storage medium **112** may comprise executable instructions configured to cause the computing device **104** (e.g., processor **111**) to perform steps of one or more of the methods disclosed herein.

(38) According to various embodiments, a non-volatile memory controller **126** may manage one or more non-volatile memory device(s) **118** and/or non-volatile memory element(s) **122**. The non-volatile memory device(s) **118** may comprise recording, memory, and/or storage devices, such as solid-state storage device(s) and/or semiconductor storage device(s) that are arranged and/or partitioned into a plurality of addressable storage locations. As used herein, a storage location refers

to any physical unit of memory (e.g., any quantity of physical storage media on a non-volatile memory device(s) **118**). Memory units may include, but are not limited to: pages, memory divisions, blocks, data blocks, memory blocks, sectors, collections or sets of physical storage locations (e.g., logical pages, logical blocks, logical memory blocks), or the like.

(39) A device driver and/or the non-volatile memory controller **126**, in certain embodiments, may present a logical address space **136** to the storage client(s) **116**. As used herein, a logical address space **136** refers to a logical representation of memory resources. The logical address space **136** may comprise a plurality (e.g., range) of logical addresses. As used herein, a logical address refers to any identifier for referencing a memory resource (e.g., data), including, but not limited to: a logical block address (LBA), cylinder/head/sector (CHS) address, a file name, an object identifier, an inode, a Universally Unique Identifier (UUID), a Globally Unique Identifier (GUID), a hash code, a signature, an index entry, a range, an extent, or the like.

(40) A device driver for the non-volatile memory device(s) **118** may maintain metadata **138**, such as a logical to physical address mapping structure, to map logical addresses of the logical address space **136** to storage location on the non-volatile memory device(s) **118**. A device driver may be configured to provide storage services to one or more storage client(s) **116**. The storage client(s) **116** may include local storage client(s) **116** operating on the computing device **104** and/or remote, storage client(s) **116** accessible via the network **114** and/or communication interface **110**. The storage client(s) **116** may include, but are not limited to: operating systems, file systems, database applications, server applications, kernel-level processes, user-level processes, applications, and the like.

(41) A device driver may be communicatively coupled to one or more non-volatile memory device(s) **118**. The one or more non-volatile memory device(s) **118** may include different types of non-volatile memory devices including, but not limited to: solid-state storage devices, semiconductor storage devices, SAN storage resources, or the like. The one or more non-volatile memory device(s) **118** may comprise one or more of a respective non-volatile memory controller **126** and/or non-volatile memory media **120**. A device driver may provide access to the one or more non-volatile memory device(s) **118** via a traditional block I/O interface **132**. Additionally, a device driver may provide access to other functionality through the storage class memory interface (SCM interface **134**). The metadata **138** may be used to manage and/or track data operations performed through any of the block I/O interface **132**, SCM interface **134**, or other, related interfaces.

(42) In one embodiment, a user application such as software application operating on or in conjunction with the storage client(s) **116** uses the non-volatile memory system **102**. The storage client(s) **116** manage files and data and utilizes the functions and features of the non-volatile memory controller **126** and associated non-volatile memory media **120**. Representative examples of storage clients include, but are not limited to, a server, a file system, an operating system, a database management system (“DBMS”), a volume manager, and the like. In one embodiment, the storage client(s) **116** access to the one or more non-volatile memory device(s) **118** via a traditional block I/O interface **132**.

(43) Certain conventional block storage devices divide the storage media into volumes or partitions. Each volume or partition may include a plurality of sectors. One or more sectors are organized into a block (also referred to as a data block). In certain storage systems, such as those interfacing with the Windows® operating systems, the data blocks are referred to as clusters. In other storage systems, such as those interfacing with UNIX, Linux, or similar operating systems, the data blocks are referred to simply as blocks. A block or cluster represents a smallest physical amount of storage space on the storage media that is managed by the non-volatile memory controller **126**. A block storage device may associate n blocks available for user data storage across the non-volatile memory media **120** with a logical block address, numbered from 0 to n. In certain block storage devices, the logical block addresses may range from 0 to n per volume or partition. In conventional block storage devices, a logical block address maps directly to a particular logical

block.

(44) A device driver may present a logical address space **136** to the storage client(s) **116** through one or more interfaces. As discussed above, the logical address space **136** may comprise a plurality of logical addresses, each corresponding to respective storage locations within the one or more non-volatile memory device(s) **118**. A device driver may maintain metadata **138** comprising any-to-any mappings between logical addresses and storage locations, or the like.

(45) A device driver may further comprise and/or be in communication with a non-volatile memory device interface **140** configured to transfer data, commands, and/or queries to the one or more non-volatile memory device(s) **118** over a bus **124**, which may include, but is not limited to: a memory bus of a processor **106**, a peripheral component interconnect express (PCI Express or PCIe) bus, a serial Advanced Technology Attachment (ATA) bus, a parallel ATA bus, a small computer system interface (SCSI), FireWire, Fibre Channel, a Universal Serial Bus (USB), a PCIe Advanced Switching (PCIe-AS) bus, a network **114**, Infiniband, SCSI RDMA, non-volatile memory express (NVMe), or the like. The non-volatile memory device interface **140** may communicate with the one or more non-volatile memory device(s) **118** using input-output control (IO-CTL) command(s), IO-CTL command extension(s), remote direct memory access, or the like.

(46) The communication interface **110** may comprise one or more network interfaces configured to communicatively couple the computing device **104** and/or the non-volatile memory controller **126** to a network **114** and/or to one or more remote, network-accessible storage client(s) **116**. The storage client(s) **116** may include local storage client(s) **116** operating on the computing device **104** and/or remote, storage client(s) **116** accessible via the network **114** and/or the communication interface **110**. The non-volatile memory controller **126** is part of and/or in communication with one or more non-volatile memory device(s) **118**. Although FIG. 1 depicts a single non-volatile memory device(s) **118**, the disclosure is not limited in this regard and could be adapted to incorporate any number of non-volatile memory device(s) **118**.

(47) The non-volatile memory device(s) **118** may comprise one or more non-volatile memory element(s) **122** of non-volatile memory media **120**, which may include but is not limited to: ReRAM, Memristor memory, programmable metallization cell memory, phase-change memory (PCM, PCME, PRAM, PCRAM, ovonic unified memory, chalcogenide RAM, or C-RAM), NAND flash memory (e.g., 2D NAND flash memory, 3D NAND flash memory), NOR flash memory, nano random access memory (nano RAM or NRAM), nanocrystal wire-based memory, silicon-oxide based sub-10 nanometer process memory, graphene memory, Silicon-Oxide-Nitride-Oxide-Silicon (SONOS), programmable metallization cell (PMC), conductive-bridging RAM (CBRAM), magneto-resistive RAM (MRAM), magnetic storage media (e.g., hard disk, tape), optical storage media, or the like. The one or more non-volatile memory element(s) **122** of non-volatile memory media **120**, in certain embodiments, comprise storage class memory (SCM).

(48) While legacy technologies such as NAND flash may be block and/or page addressable, storage class memory, in one embodiment, is byte addressable. In further embodiments, storage class memory may be faster and/or have a longer life (e.g., endurance) than NAND flash; may have a lower cost, use less power, and/or have a higher storage density than DRAM; or offer one or more other benefits or improvements when compared to other technologies. For example, storage class memory may comprise one or more non-volatile memory element(s) **122** of ReRAM, Memristor memory, programmable metallization cell memory, phase-change memory, nano RAM, nanocrystal wire-based memory, silicon-oxide based sub-10 nanometer process memory, graphene memory, SONOS memory, PMC memory, CBRAM, MRAM, and/or variations thereof.

(49) While the non-volatile memory media **120** is referred to herein as “memory media,” in various embodiments, the non-volatile memory media **120** may more generally comprise one or more non-volatile recording media capable of recording data, which may be referred to as a non-volatile memory medium, a non-volatile storage medium, or the like. Further, the non-volatile memory device(s) **118**, in various embodiments, may comprise a non-volatile recording device, a non-

volatile memory device, a non-volatile storage device, or the like.

(50) The non-volatile memory media **120** may comprise one or more non-volatile memory element(s) **122**, which may include, but are not limited to: chips, packages, planes, die, or the like. A non-volatile memory controller **126** may be configured to manage data operations on the non-volatile memory media **120**, and may comprise one or more processors, programmable processors (e.g., FPGAs), ASICs, micro-controllers, or the like. In some embodiments, the non-volatile memory controller **126** is configured to store data on and/or read data from the non-volatile memory media **120**, to transfer data to/from the non-volatile memory device(s) **118**, and so on.

(51) The non-volatile memory controller **126** may be communicatively coupled to the non-volatile memory media **120** by way of a bus **128**. The bus **128** may comprise a bus for communicating data to/from the non-volatile memory element(s) **122**. The bus **128**, in one embodiment, may further comprise a control bus for communicating addressing and other command and control information to the non-volatile memory element(s) **122**. In some embodiments, the bus **128** may communicatively couple the non-volatile memory element(s) **122** to the non-volatile memory controller **126** in parallel. This parallel access may allow the non-volatile memory element(s) **122** to be managed as a group, forming a logical memory element **130**. The logical memory element **130** may be partitioned into respective logical memory units (e.g., logical pages) and/or logical memory divisions (e.g., logical data blocks, logical blocks, logical memory blocks). The logical memory units may be formed by logically combining physical memory units of each of the non-volatile memory element(s) **122**.

(52) In some embodiments, the non-volatile memory controller **126** may be configured to store data on one or more asymmetric, write-once media, such as non-volatile memory media **120**. As used herein, a “write once” storage medium refers to a storage medium that is reinitialized (e.g., erased) each time new data is written or programmed thereon. As used herein, an “asymmetric” storage medium refers to a storage medium having different latencies for different storage operations. Many types of non-volatile memory media **120** are asymmetric; for example, a read operation may be much faster than a write/program operation, and a write/program operation may be much faster than an erase operation (e.g., reading the media may be hundreds of times faster than erasing, and tens of times faster than programming the media).

(53) The non-volatile memory media **120** may be partitioned into memory divisions that can be erased as a group (e.g., memory blocks) in order to, inter alia, account for the asymmetric properties of the media. As such, modifying a single data sector or data block in-place may require erasing the entire memory block comprising the data, and rewriting the modified data to the memory block, along with the original, unchanged data. This may result in inefficient “write amplification,” which may excessively wear the non-volatile memory media **120**.

(54) Therefore, in some embodiments, the non-volatile memory controller **126** may be configured to write data out-of-place. As used herein, writing data “out-of-place” refers to writing data to different physical storage location(s) rather than overwriting the data “in-place” (e.g., overwriting the data in the original physical location). Modifying data out-of-place may avoid write amplification, since existing, valid data on the memory block with the data to be modified need not be erased and rewritten. Moreover, writing data out-of-place may remove erasure from the latency impact of certain storage operations.

(55) The non-volatile memory controller **126** may be organized according to a plurality of memory blocks of word lines within a non-volatile memory element(s) **122**, in certain embodiments, using addresses of the word lines, such that the word lines are logically organized into a monotonically increasing sequence (e.g., decoding and/or translating addresses for word lines into a monotonically increasing sequence, or the like). In a further embodiment, word lines of a memory block within a non-volatile memory element(s) **122** may be physically arranged in a monotonically increasing sequence of word line addresses, with consecutively addressed word lines also being physically adjacent (e.g., WL0, WL1, WL2, . . . WLN).

(56) The non-volatile memory controller **126** may comprise and/or be in communication with a device driver executing on the computing device **104**. A device driver may provide storage services to the storage client(s) **116** via one or more interfaces (block I/O interface **132**, SCM interface **134**, and/or others). In some embodiments, a device driver provides a computing device **104** block I/O interface **132** through which storage client(s) **116** perform block-level I/O operations. Alternatively, or in addition, a device driver may provide an SCM interface **134**, which may provide other storage services to the storage client(s) **116**. In some embodiments, the SCM interface **134** may comprise extensions to the block I/O interface **132** (e.g., storage client(s) **116** may access the SCM interface **134** through extensions or additions to the block I/O interface **132**). Alternatively, or in addition, the SCM interface **134** may be provided as a separate API, service, and/or library.

(57) A device driver may further comprise a non-volatile memory device interface **140** that is configured to transfer data, commands, and/or queries to the non-volatile memory controller **126** over a bus **124**, as described above.

(58) FIG. 2A illustrates an embodiment of a non-volatile storage system **200** that may include one or more memory die(s) **202** or chips. Memory die(s) **202**, in some embodiments, include a memory array **204** (two-dimensional or three dimensional) of memory cells, die controller **206**, read/write circuits A **222**, and read/write circuits B **224**. In one embodiment, access to the memory array **204** by the various peripheral circuits is implemented in a symmetric fashion, on opposite sides of the array, so that the densities of access lines and circuitry on each side are reduced by half. The read/write circuits A **222** and read/write circuits B **224**, in a further embodiment, include multiple sense amplifiers **230** which allow a page of memory cells to be read or programmed in parallel.

(59) The memory array **204**, in various embodiments, is addressable by word lines via row decoder A **218** and row decoder B **220** and by bit lines via column decoder A **226** and column decoder B **228**. In some embodiments, a controller **216** is included in the same memory system **200** (e.g., a removable storage card or package) as the one or more memory die(s) **202**. Commands and data are transferred between the host device **232** and controller **216** via lines **214** and between the controller and the one or more memory die(s) **202** via lines **212**. One implementation can include multiple memory die(s) **202**.

(60) Die controller **206**, in one embodiment, cooperates with the read/write circuits A **222** and read/write circuits B **224** to perform storage/memory operations on the memory array **204**. The die controller **206**, in certain embodiments, includes a voltage driver **234**, a state machine **208**, and an on-chip address decoder **210**. In one embodiment, the state machine **208** comprises at least a portion of the voltage driver **234**. In another embodiment, the controller **216** comprises at least a portion of the voltage driver **234**.

(61) The voltage driver **234**, in one embodiment, is configured to supply a voltage to one or more components of the memory array. The magnitude of the voltage and whether the voltage level supplied is increasing or decreasing depends on the operation that the die controller **206** is implementing. At one point during an operation, the voltage level provided by the voltage driver **234** may comprise an analog signal increasing from ground or zero voltage, or a level substantially close to zero, to a desired voltage level required by components coupled to the voltage driver **234** to implement the desired operation. As the voltage applied to a component coupled to the voltage driver **234** increases, the period of time during which the voltage level is changing is referred to herein as charging, pre-charging, or ramping up.

(62) At another point during an operation, the voltage level provided by the voltage driver **234** may comprise an analog signal configured to maintain a voltage level required by components coupled to the voltage driver **234** for a particular stage of implementing a desired operation. As the voltage applied to a component coupled to the voltage driver **234** remains substantially at the desired voltage level, the period of time is referred to herein as a steady state or stable.

(63) At another point during an operation, the voltage level provided by the voltage driver **234** may comprise an analog signal decreasing from a desired voltage level to a lower voltage level, a

ground level, or zero voltage, or a level substantially close to zero, for a desired operation. As the voltage applied to a component coupled to the voltage driver **234** decreases the period during which the voltage level is changing is referred to herein as discharging, post-charging, or ramping down.

(64) The state machine **208**, in one embodiment, provides chip-level control of storage and/or memory operations. The on-chip address decoder **210** provides an address interface to convert between the address that is used by the host or a memory controller to the hardware address used by the row decoder A **218**, row decoder B **220**, column decoder A **226** a, and column decoder B **228**. The state machine **208** includes logic for activating and controlling the voltage driver **234** and other logic coupled to circuits in electrical communication with the voltage driver **234**.

(65) In one embodiment, one or any combination of die controller **206**, voltage driver **234**, on-chip address decoder **210**, state machine **208**, row decoder A **218**, row decoder B **220**, column decoder A **226**, column decoder B **228**, read/write circuits A **222**, read/write circuits B **224**, and/or controller **216** can be referred to as one or more managing circuits.

(66) Generally, control code can be included to perform the functions described herein including the steps of the flowcharts discussed further below. For example, as illustrated in FIG. **2B**, the controller **216** or any other circuitry in the memory system **200** is configured to program the memory cells of a selected word line according to unique programming techniques discussed herein. At step **236**, programming of a selected word line WL_n begins. At step **238**, the controller **216** determines which zone of the memory block the selected word line WL_n is located within. At step **240**, a maximum programming voltage VPGM_{max} is set based on the zone that the selected word line WL_n is located within. At step **242**, the controller programs the memory cells of the selected word line WL_n in a plurality of program loops without a programming voltage VPGM exceeding the maximum programming voltage VPGM_{max}.

(67) FIG. **3** depicts one embodiment of a NAND string **300** comprising a plurality of memory cells. The NAND string **300** depicted in FIG. **3**, in some embodiments, includes four transistors (transistor **302**, transistor **304**, transistor **306**, and transistor **308**) connected in series and located between a first select transistor **310** and a second select transistor **312**. In some embodiments, the transistor **302**, transistor **304**, transistor **306**, and transistor **308** each include a control gate with a charge trap layer **330**. Control gate **322**, control gate **324**, control gate **326**, and control gate **328**, in one embodiment, are connected to, or comprise portions of word lines WL₀-WL₃ respectively. In a further embodiment, transistor **302**, transistor **304**, transistor **306**, and transistor **308** are memory cells, storage elements, or the like, also referred to as memory cells. In some embodiments, a single memory cell may include multiple transistors.

(68) The first select transistor **310**, in some embodiments, gates/connects the NAND string **300** to a bit line **314** via a drain select gate/select gate drain (SGD). The second select transistor **312**, in certain embodiments, gates/connects the NAND string **300** to a source line **316** via a source select gate/select gate source (SGS). The first select transistor **310**, in a further embodiment, is controlled by applying a voltage to a corresponding select gate **318**. The second select transistor **312**, in some embodiments, is controlled by applying a voltage to corresponding select gate **320**.

(69) As shown in FIG. **3**, the source line **316**, in one embodiment, is connected to the sources of each transistor/memory cell in the NAND string **300**. The NAND string **300**, in some embodiments, may include some memory cells that have been programmed and some memory cells that have not been programmed.

(70) FIG. **4** is a circuit diagram depicting a memory array **400** comprising a plurality of NAND strings. An architecture for a memory array using a NAND structure may include a significant number of NAND strings. For example, FIG. **4** illustrates a memory array **400** that includes NAND string **404**, NAND string **420**, NAND string **436**, and NAND string **452**. In the depicted embodiment, each NAND string includes drain select transistors (select transistor **408**, select transistor **424**, select transistor **440**, and select transistor **456**), source select transistors (select

transistor **418**, select transistor **434**, select transistor **450**, select transistor **466**), and memory cells (memory cell **410**, memory cell **412**, memory cell **414**, memory cell **416**, memory cell **426**, memory cell **428**, memory cell **430**, memory cell **432**, memory cell **442**, memory cell **444**, memory cell **446**, memory cell **448**, memory cell **458**, memory cell **460**, memory cell **462**, and memory cell **464**). The memory cells may be transistors that incorporate a charge trap layer **468**. While four memory cells per NAND string are illustrated for simplicity, some NAND strings can include any number of memory cells, e.g., thirty-two, sixty-four, or the like memory cells.

(71) NAND string **404**, NAND string **420**, NAND string **436**, and NAND string **452**, in one embodiment, are connected to a source line **402** by source select transistor **418**, select transistor **434**, select transistor **450**, and select transistor **466**, respectively. A source select line SGS may be used to control the source side select transistors, **418**, **434**, **450**, **466**. The various NAND strings, in one embodiment, are connected to bit line **406**, bit line **422**, bit line **438**, and bit line **454** by drain select transistor **408**, select transistor **424**, select transistor **440**, and select transistor **456**, respectively, as shown. The drain select transistors may be controlled by a drain select line SGD. In some embodiments, the select lines do not necessarily need to be in common among the NAND strings; that is, different select lines can be provided for different NAND strings.

(72) As described above, each word line WL0-WLn connects one or more memory cells. In the depicted embodiment, bit line **406**, bit line **422**, bit line **438**, and bit line **454**, and the respective NAND string **404**, NAND string **420**, NAND string **436**, and NAND string **452**, form the respective columns of the memory array **400**, storage block, memory block, or the like. These columns may also be referred to as channels. The word lines WL0-WLn, in some embodiments, comprise the rows of the memory array **400**, storage block, memory block, or the like. Each word line WL0-WLn, in some embodiments, connects the control gates of each memory cell in a row. Alternatively, the control gates may be provided by the word lines WL0-WLn themselves. In some embodiments, a word line WL0-WLn may include tens, hundreds, thousands, millions, or the like of memory cells.

(73) In one embodiment, each memory cell is configured to store data. For example, when storing one bit of digital data, the range of possible threshold voltages (V_t) of each memory cell may be divided into two ranges which are assigned logical data “1” and “0.” As used herein, threshold voltage refers to a magnitude of voltage applied to the gate of a memory cell sufficient to cause the memory cell to activate. In embodiments, in which the memory cell is a NAND transistor, the threshold voltage is a sufficient voltage applied to a gate terminal of the transistor that causes the transistor to conduct current between its source terminal and drain terminal. In one example of a NAND type flash memory, the V_t may be negative after the memory cells are erased, and defined as logic “1.” In one embodiment, the V_t after a program operation is positive and defined as logic “0.”

(74) When the V_t is negative and a read is attempted, in some embodiments, memory cells will turn on to indicate logic “1” is being stored. When the V_t is positive and a read operation is attempted, in a further embodiment, a memory cell will not turn on, which indicates that logic “0” is stored. Each memory cell may also store multiple levels of information, for example, multiple bits of digital data. In such an embodiment, the range of V_t value is divided into the number of levels of data. For example, if four levels of information can be stored in each memory cell, there will be four V_t ranges assigned to the data values “11”, “10”, “01”, and “00.”

(75) In one example of a NAND type memory, the V_t after an erase operation may be negative and defined as “11.” Positive V_t values may be used for the states of “10”, “01”, and “00.” In one embodiment, the specific relationship between the data programmed into the memory cells and the threshold voltage ranges of the memory cells depends upon the data encoding scheme adopted for the memory cells.

(76) FIGS. 5-7 depict different views of an example three dimensional memory array. FIG. 5 is a block diagram depicting a top view of a portion of three dimensional memory array. As can be seen

from FIG. 5, the memory array extends **530** in the direction of the arrows shown. In one embodiment, the memory array may have between 60-128 layers. Other embodiments may have less than or more than 60-128 layers. However, FIG. 5 shows the top layer.

(77) FIG. 5 depicts a top view of a portion of a memory array **500**. A plurality of circles represent the vertical columns (e.g., vertical column **522** and vertical column **524** also referred to as channels). Each of the vertical columns includes multiple select transistors and multiple memory cells. In one embodiment, each of the vertical columns implements a NAND string. More details of the vertical columns are provided below. Since the memory array extends **530** in the direction of the two arrows shown, a memory block includes more vertical columns **522** than depicted in FIG. 5.

(78) FIG. 5 also depicts a set of bit lines **514**. FIG. 5 shows twenty-four bit lines because only a portion of a memory block is depicted. It is contemplated that more than twenty-four bit lines are connected to vertical columns of the memory block. Each of the circles representing vertical columns has an “x” to indicate its connection to one bit line **516**.

(79) The portion of memory block depicted in FIG. 5 includes a set of openings (trench **504**, trench **506**, trench **508**, trench **510**, and trench **512**). A trench separates layers of the three-dimensional array so that smaller divisions can be used in particular storage operations. For example, in FIG. 5, the trenches, together with separate source line connections, break up a monolithic memory array into portions **518**, **520**, **526**, **528** of four illustrated memory blocks. These trenches facilitate performing an erase operation on one memory block without adversely impacting other memory blocks. Trenches may also be used for other routing signals and in such embodiments be referred to as interconnects or local interconnects. For example, in one embodiment, connections to a source gate select line may connect to the source line by way of a line within one or more trenches.

(80) Although FIG. 5 shows each region having four rows of vertical columns, four portions and sixteen rows of vertical columns, those exact numbers are an example implementation. Other embodiments may include more or less regions, more or less rows of vertical columns per region and more or less rows of vertical columns per block.

(81) FIG. 5 also shows the vertical columns being staggered. In other embodiments, different patterns of staggering can be used. In some embodiments, the vertical columns are not staggered.

(82) FIG. 6 depicts a portion of an embodiment of the non-volatile memory media **120** showing a cross-sectional view of a portion of a memory array **600**. As indicated in FIG. 5, this cross-sectional view cuts through vertical column **522** and vertical column **524** and **520** (see FIG. 5). The structure of FIG. 6 includes four drain side select layers SGD0, SGD1, SGD2, and SGD3; four source side select layers SGS0, SGS1, SGS2, and SGS3; four dummy word line layers DWLL1 a, DWLL1 b, DWLL2 a, and DWLL2 b; and forty-eight data word line layers WLL0-WLL47 for connecting to data memory cells. Other embodiments can implement more or less than four drain side select layers, more or less than four source side select layers, more or less than four dummy word line layers, and more or less than forty-eight word line layers. Vertical column **522** and vertical column **524** are depicted protruding through the drain side select layers, source side select layers, dummy word line layers and word line layers. In one embodiment, each vertical column comprises a NAND string. Below the vertical columns and the layers listed below is a substrate **602**, an insulating film **604** on the substrate **602**, and source line **316** (SL). The NAND string of vertical column **522** has a source end at a bottom of the stack and a drain end at a top of the stack. As in agreement with FIG. 5, FIG. 6 shows vertical column **522** connected to bit line **516** via connector **606**. Trench **506** and trench **508** are also depicted. Portions of a memory block **518** and **526** extend to either side of the portion shown.

(83) For ease of reference, drain side select layers SGD0, SGD1, SGD2, and SGD3; source side select layers SGS0, SGS1, SGS2, and SGS3; dummy word line layers DWLL1 a, DWLL1 b, DWLL2 a, and DWLL2 b; and word line layers WLL0-WLL47 collectively are referred to as the conductive layers. In one embodiment, the conductive layers are made from a combination of TiN

and Tungsten. In other embodiments, other materials can be used to form the conductive layers, such as doped polysilicon, metal such as Tungsten, or metal silicide. In some embodiments, different conductive layers can be formed from different materials. Between conductive layers are dielectric layers DL0-DL59. For example, dielectric layers DL49 is above word line layer WLL43 and below word line layer WLL44. In one embodiment, the dielectric layers are made from SiO₂. In other embodiments, other dielectric materials may be used to form the dielectric layers.

(84) The non-volatile memory cells are formed along vertical columns (also referred to as channels) which extend through alternating conductive and dielectric layers in the stack. In one embodiment, the memory cells are arranged in NAND strings. The word line layers WLL0-WLL47 connect to memory cells (also called memory cells or data memory cells). Dummy word line layers DWLL1 a, DWLL1 b, DWLL2 a, and DWLL2 b connect to dummy memory cells. A dummy memory cell does not store user data, while a data memory cell is eligible to store user data. Drain side select layers SGD0, SGD1, SGD2, and SGD3 are used to electrically connect and disconnect NAND strings from bit lines. Source side select layers SGS0, SGS1, SGS2, and SGS3 are used to electrically connect and disconnect NAND strings from the source line **316** SL. The memory array **700** shown is illustrated in more detail in FIG. 7.

(85) FIG. 7 illustrates a cross-sectional view of a memory array **700**. In one embodiment, the vertical column **522** is round and includes four layers; however, in other embodiments more or less than four layers can be included and other shapes can be used (e.g., a “U” shape instead of an “I” shape or the like). In one embodiment, a vertical column **522** includes an inner core layer **702** that is made of a dielectric, such as SiO₂. Other materials can also be used. Surrounding the inner core layer **702** is a polysilicon channel **704**. Materials other than polysilicon can also be used. Note that it is the channel **704** that connects to the bit line. Surrounding the channel **704** is a tunneling dielectric **706**. In one embodiment, tunneling dielectric **706** has an ONO structure. Surrounding the tunneling dielectric **706** is a shared charge trapping layer **708**, such as (for example) Silicon Nitride. Other materials and structures can also be used. The technology described herein is not limited to any particular material or structure.

(86) FIG. 7 depicts dielectric layers DL49, DL50, DL51, DL52, and DL53, as well as word line layers WLL43, WLL44, WLL45, WLL46, and WLL47. Each of the word line layers includes a word line region **710** surrounded by an aluminum oxide layer **712**, which is surrounded by a blocking oxide layer **714**, which may be of SiO₂. The physical interaction of the word line layers with the vertical column forms the memory cell (also referred to as a memory cell). Thus, a memory cell, in one embodiment, comprises channel **704**, tunneling dielectric **706**, charge trapping layer **708** (e.g., shared with other memory cells), blocking oxide layer **714**, aluminum oxide layer **712** and word line region **710**. In some embodiments, the blocking oxide layer **714** and aluminum oxide layer **712**, may be replaced by a single layer of material with insulating properties or by more than 2 layers of different material with insulating properties. Furthermore, the materials used are not limited to silicon dioxide (SiO₂) or aluminum oxide.

(87) For example, word line layer WLL47 and a portion of vertical column **522** comprise a memory cell MC1. Word line layer WLL46 and a portion of vertical column **522** comprise a memory cell MC2. Word line layer WLL45 and a portion of vertical column **522** comprise a memory cell MC3. Word line layer WLL44 and a portion of vertical column **522** comprise a memory cell MC4. Word line layer WLL43 and a portion of vertical column **522** comprise a memory cell MC5. In other architectures, a memory cell may have a different structure; however, the memory cell would still be the data storage unit.

(88) When a memory cell is programmed, electrons are stored in a portion of the charge trapping layer **708** which is associated with the memory cell. These electrons are drawn into the charge trapping layer **708** from the channel **704** through the tunneling dielectric **706**, in response to an appropriate voltage on word line region **710**. The threshold voltage (V_t) of a memory cell is increased in proportion to the amount of stored charge. In one embodiment, the programming is

achieved through Fowler-Nordheim tunneling of the electrons into the charge trapping layer. During an erase operation, the electrons return to the channel or holes are injected into the charge trapping layer to recombine with electrons. In one embodiment, erasing is achieved using hole injection into the charge trapping layer via a physical mechanism such as gate induced drain leakage (GIDL).

(89) Memory cells in the same location or position in different memory structures (e.g., different NAND strings) on different bit lines, in certain embodiments, may be on the same word line. Each word line may store one page of data, such as when 1-bit of data is stored per single-level cell (SLC); two pages of data, such as when 2-bits of data are stored per multi-level cell (MLC); three pages of data, such as when 3-bits of data are stored per triple-level cell (TLC); four pages of data, such as when 4-bits of data are stored per quad-level cell (QLC); or another number of pages of data.

(90) In the depicted embodiment, a vertical, 3D NAND flash memory structure comprises an “I” shaped memory structure. In other embodiments, a vertical, 3D NAND flash memory structure may comprise a “U” shaped structure, or may have another vertical and/or stacked architecture. In certain embodiments, four sets of strings (e.g., four sets of 48 word lines, or another predefined number of word lines) may form a memory block, while in other embodiments, fewer or more than four sets of strings may form a memory block. As may be appreciated, any suitable number of memory cells may be part of a single NAND string. In one embodiment, a NAND string includes forty-eight (48) memory cells. In other embodiments, a NAND string includes one hundred and twelve (112) or more memory cells.

(91) FIG. 8 shows word lines driven from one side **800**. Eight memory blocks of memory are shown: BLK0 **802**, BLK1 **806**, BLK2 **810**, BLK3 **814**, BLK4 **818**, BLK5 **822**, BLK6 **826**, and BLK7 **830**. Note that these numbers are used solely for labeling purposes, and are not intended to represent an exact physical location within a memory array. These memory blocks may be configured as described in FIG. 5-FIG. 7.

(92) As used herein, a “memory block” comprises a set of memory cells organized within a memory array such that an erase storage operation impacts each of the memory cells within the memory block. Ideally, each memory cell of the memory block transitions to an erased state due to the erase storage operation. In practice, certain memory cells may not transition to an erased state and therefore are in an error state due to not erasing properly.

(93) A single conductive layer may underlie all of the memory blocks and provide a common source line **834**. This corresponds to the source line **402** shown in FIG. 4. To the left and the right side of each memory block, as this drawing is oriented, a stair case region **836** may exist. In this region **836**, connections may be made between word line layers and high voltage WLSWs which are connected of one or more voltage sources that are referred to herein as drivers. The gates used to drive memory command signals and to switch those signals to specific locations in memory may, at least in part, reside in, and connect through, the stair case region **836**.

(94) Word lines are conventionally driven from only one side because of the area required for the row decoder logic illustrated in FIG. 2. (e.g., row decoder A **218** and row decoder B **220**) In a conventional architecture for the memory array, the silicon area needed for the row decoders to drive each word line from both sides would need to be twice the conventional area used for row decoders that drive each word line from only one side.

(95) In a conventional memory array, the row decoders on either side of the memory array are configured to drive half of the word lines and/or memory blocks. In order to accommodate the logic and connections needed for each block, a conventional die layout alternates which sets of high voltage WLSWs of the stair case region **836** adjacent to a memory block will connect to and drive the word lines within the memory block.

(96) This alternating connection pattern is illustrated in FIG. 8 using solid and dotted lines to show which stair case region comprising the word line switches (WLSWs) that control each memory

block. Starting at the bottom, BLK0 **802** is controlled and/or driven by the BLK0 WLSWs **804** located to the right, while BLK1 **806** is controlled and/or driven by the BLK1 WLSWs **808** to the left. BLK2 **810** is controlled and/or driven by BLK2 WLSWs **812** to the right, and BLK3 **814** is controlled and/or driven by BLK3 WLSWs **816** to the left. BLK4 **818** is controlled and/or driven by BLK4 WLSWs **820**, BLK5 **822** by BLK5 WLSWs **824**, BLK6 **826** by BLK6 WLSWs **828**, and BLK7 **830** by BLK7 WLSWs **832**.

(97) FIG. **9** illustrates a top down view of a memory array **900** in accordance with one embodiment. Certain details are not illustrated (e.g., bit lines and vertical columns) for clarity in illustrating other elements.

(98) The memory array **900** includes a three-dimensional array of memory cells organized into rows and columns. The rows comprise a plurality of word lines and the columns connect to bit lines. The word lines are organized into memory blocks BLK0 **802**, BLK1 **806**, BLK2 **810**, BLK3 **814**, BLK4 **818**, BLK5 **822**, BLK6 **826**, and BLK7 **830**.

(99) Memory cells within the memory array connect to the die controller **206** by way of row decoder A **218**, row decoder B **220**, column decoder A **226**, and column decoder B **228**. The die controller **206** supplies voltages and/or currents to circuits and logic of the decoders to implement storage operations such as reading memory cells, writing memory cells, and/or erasing memory cells.

(100) In particular, the row decoders and/or column decoders include logic, such as switches, for selectively connecting the memory cells to a voltage driver such as, voltage driver **234** (See FIG. **2**). In one embodiment, the memory array includes a connection circuit. A connection circuit is any electrical circuit configured to electrically couple one or more circuit drivers (voltage and/or current) to two ends of a word line. In certain embodiments, a connection circuit includes one or more gates or switches to enable either selective coupling, or substantially simultaneous coupling, of certain components to the driver(s). The connection circuit provides an electrical conductive path that includes one or more word lines in a first set of word lines, one or more word lines in a second set of word lines and a common driver, such as voltage driver **234**.

(101) In certain embodiments, the connection circuit includes a plurality of switches (e.g., **902**, **904**, **906**, **908**, **910**, **912**, **914**, **916**) positioned in the stair case region **836**. The switches selectively connect each word line of a memory block to the voltage driver **234**. In one embodiment, the switch is a transistor with one terminal in electrical communication to a word line and the other terminal in electrical communication with the voltage driver **234** and the gate in electrical communication with the die controller **206** (e.g., state machine **208**).

(102) In the embodiment illustrated in FIG. **9**, the connection circuit **926** electrically connects a first word line in one memory block, (e.g., BLK0 **802**) and a second word line in an adjacent memory block, (e.g., BLK1 **806**) to the same voltage driver **234**. In certain embodiments, the connection circuit **926** includes circuits, logic, or the like, to enable the state machine **208** to activate a switch positioned on one side of the memory block (e.g., BLK0 **802**) and to substantially simultaneously activate a switch positioned on an opposite end of the memory block (e.g., BLK1 **806**). In this manner, the state machine **208**, voltage driver **234**, and connection circuit **926** work together to supply a voltage signal (e.g., bias) to both the second word line and the first word line from both ends at substantially the same time.

(103) As used herein, an adjacent memory block comprises a memory block positioned next to or in close proximity to an existing memory block, with no other memory blocks between them. In the embodiment illustrated in FIG. **9**, BLK0 **802** and BLK1 **806** are representative examples of adjacent memory blocks. Conversely, BLK0 **802** and BLK2 **810** are not adjacent memory blocks because BLK1 **806** is positioned between them.

(104) As mentioned above, analog circuits, such as those of the word lines, experience resistive-capacitive (RC) loading when a voltage is applied. As explained in relation to FIG. **3**, voltage applied to the word line is applied to the gate of the memory cells along the word line to bias a

memory cell for a storage operation.

(105) A memory array **900** configured with the state machine **208**, voltage driver **234** (see FIG. 2), and connection circuit **926** adjusts a voltage signal (e.g., bias) on the second word line and the first word line from both ends at substantially the same time which mitigates delay caused by RC loading. FIG. 8 illustrates an embodiment from a top view, consequently, details of connections between one word line in a selected memory block, such as BLK0 **802** and another word line in an unselected memory block, such as word line layers and/or connection circuits of the memory array that are below this top level view are not shown here for clarity. However, these details are included in subsequent figures of other embodiments. It should be noted that in the embodiments described herein, each word line within a selected memory block of a three-dimensional array is coupled to a corresponding word line in an adjacent memory block of the three-dimensional array.

(106) In order to reduce the latency incurred in propagating a signal across the entire length of a word line, in some embodiments, the WLSWs (of the connection circuit) may be located on both sides of a pair of adjacent memory blocks to drive signals onto word line layers from both ends.

(107) As illustrated, in the depicted embodiment, WLSWs located in both stair case regions are used to drive the even and odd adjacent memory blocks.

(108) BLK0+BLK1 WLSWs **902** and BLK0+BLK1 WLSWs **904** both drive BLK0 **802** as well as BLK1 **806**. BLK2+BLK3 WLSWs **906** and BLK2+BLK3 WLSWs **908** drive BLK2 **810** and BLK3 **814**. BLK4+BLK5 WLSWs **910** and BLK4+BLK5 WLSWs **912** drive BLK4 **818** and BLK5 **822**. BLK6+BLK7 WLSWs **914** and BLK6+BLK7 WLSWs **916** drive BLK6 **826** and BLK7 **830**.

(109) Additionally, using switches on both sides to drive both memory blocks, rather than alternating driving gates for a single memory block from one side to the other, reduces the RC delay and propagation latency, without increasing the row decoder (e.g., row decoder A **218**, row decoder B **220**) layout area.

(110) Generally, the word lines of the memory array **900** experience voltages ranging from about 0 volts to about 20 volts. In embodiments in which the connection circuit **926** includes switches that connect both sides of one or more word lines to a common driver **234** (illustrated in FIG. 2) and the switches comprise transistors, the transistors are large in comparison to other CMOS components of the memory array **900**. Consequently, WLSWs for one memory block may occupy space vertically aligned with word lines of an adjacent memory block as well as space vertically aligned with word lines of a particular memory block. For example, in FIG. 9, switches of BLK0+BLK1 WLSWs **904** connect to both BLK0 **802** and BLK1 **806** using the same area that other designs used to connect to a single memory block.

(111) In one embodiment, the connection circuit **926** includes both one or more external conductive links **920** and one or more internal conductive links **924**. External conductive links **920** are electrical components external to (outside the perimeter of) a memory array that are configured to conduct, or pass, a voltage or current between two word lines of the memory array and voltage driver **234**. Examples of external conductive links **920** and/or components that may comprise one or more external conductive links **920**, include, but are not limited to, wires, leads, traces, metal lines, resistors, conductors, capacitors, inductors, switches, and the like.

(112) Internal conductive links **924** are electrical components internal to (within the perimeter of) a memory array that are configured to conduct, or pass, a voltage or current between two word lines of the memory array and voltage driver **234**. Examples of internal conductive links **924** and/or components that may comprise one or more internal conductive links **924**, include, but are not limited to, wires, leads, traces, metal lines, resistors, conductors, capacitors, inductors, switches, and the like. In one embodiment, the connection circuit includes just external conductive links **920** and no internal conductive links **924**.

(113) As used herein, a “selected” component refers to a component that a command, instruction, or controller, such as a die controller **206** or storage controller **216** is targeting/addressing/selecting for a particular operation. Examples of such references include selected WLSW, selected memory

cell, selected page of memory cells, selected word line, selected memory block, selected plane, selected memory die, and the like. As used herein, an “unselected” component refers to a component that a command, instruction, or controller, such as a die controller **206** or storage controller **216** is not targeting/addressing/selecting for a particular operation. Examples of such references include unselected WLSW, unselected memory cell, unselected page of memory cells, unselected word line, unselected memory block, unselected plane, unselected memory die, and the like. The operation may comprise an internal testing or maintenance operation (e.g., garbage collection, test mode operation), a user command/request, or a particular storage operation such as a read operation, write operation, or erase operation.

(114) As mentioned above, the quantity of WLSWs per memory block increases as memory devices utilize an increasing quantity of word lines in each memory block. As a result, a width a WLSW area of a CMOS layer of the memory die also increases. FIG. **10** shows a side cross-sectional view of an example memory die and illustrates a portion of the die in which WLSWs reside. The width of the area where the WLSWs are disposed (indicated as WLSW) depends on the quantity of the WLSWs, the width of each WLSW, and a shallow trench isolation (STI) space between each WLSW for providing electrical isolation. With structures such as CMOS bonded Array (CbA), the width of the area for the WLSWs is even more of an issue, because the array of memory cells can shrink dramatically. If the CMOS (complementary metal-oxide-semiconductor) footprint is larger than the array footprint, this can result in reduced chip area/cost efficiency.

(115) One purpose of the WLSWs is avoid a transfer of the bias from the control gate (CG) lines to unselected blocks. FIG. **11** shows WLSWs connected to word lines of a selected block and multiple unselected blocks along with voltages applied to gates of the WLSWs for two different schemes. Specifically referring to the left hand side, approximately zero volts may be applied to the gates of the WLSWs of the unselected blocks, while a voltage VPGMH is applied to the gates of the WLSWs of the selected block to allow a program voltage VPGM to be passed to a selected word line of the selected block and to allow the pass voltage VPASS to be passed to the unselected word lines of the selected block.

(116) FIG. **12** shows a top cross-sectional view of a portion of an example memory die illustrating dimensions of WLSWs including at least one width W and at least one length LG and at least one STI space between adjacent WLSWs.

(117) FIG. **13** is a plot of a switch threshold voltage V_{t_WLSW} of the WLSW versus a back bias V_{bs} of the WLSW for different widths of the WLSW. High voltage CMOS breakdown limits a maximum voltage of the WLSW $V_{wlswmax}$. The maximum voltage, which can be applied to the gate of the word line switch WLSW $V_{wlswmax}$, together with a maximum program voltage V_{PGMmax} , determines the width of the WLSWs. So, the maximum voltage $V_{wlswmax}$ of the WLSW equals the maximum program voltage V_{PGMmax} plus an overdrive voltage V_{ov} plus the switch threshold voltage V_{t_WLSW} of the WLSW when the switch is transferring maximum program voltage V_{PGMmax} ($V_{wlswmax} = V_{PGMmax} + V_{t_WLSW}(@ V_{bs} = V_{PGMmax}) + V_{ov}$). Since the switch threshold voltage V_{t_WLSW} when the back bias V_{bs} of the WLSW equals the maximum program voltage V_{PGMmax} increases with reducing width W, it places a constraint of minimum width W of the WLSW.

(118) Consequently, described herein is a memory apparatus (e.g., memory device **200** of FIG. **2**) including WLSWs (e.g., BLK0 WLSWs **804**, BLK1 WLSWs **808**, BLK2 WLSWs **812** BLK3 WLSWs **816** BLK4 WLSWs **820** BLK5 WLSWs **824** BLK6 WLSWs **828** BLK7 WLSWs **832** of FIG. **8** or BLK0+BLK1 WLSWs **902**, BLK0+BLK1 WLSWs **904**, BLK2+BLK3 WLSWs **906**, BLK2+BLK3 WLSWs **908**, BLK4+BLK5 WLSWs **910**, BLK4+BLK5 WLSWs **912**, BLK6+BLK7 WLSWs **914**, BLK6+BLK7 WLSWs **916** of FIG. **9**) coupled to a plurality of word lines (e.g., word line layers WLL43-WLL47 of FIG. **7**) each connected to memory cells (e.g., memory cells MC1-MC5 of FIG. **7**). The WLSWs are each configured to retain a switch threshold voltage V_{t_WLSW} and selectively connect one or more of the plurality of word lines to a common

driver (e.g., common driver **1016** OF FIG. **10**) for supplying voltages to the one or more of the plurality of word lines during a memory operation. The memory apparatus also includes a control circuit or means (e.g., one or any combination of controller **126** of FIG. **1**, die controller **206**, decoders **218**, **220**, **226**, sense blocks SBb, SB2, . . . , SBp, read/write circuits **222**, **224**, controller **216** of FIG. **2** and so forth) coupled to the WLSWs. The control means is configured to apply predetermined select block switch voltages (e.g., voltage VPGMH applied to the gates of the WLSWs of the selected block to allow a program voltage VPGM to be passed to the word lines of the selected block as in FIG. **11**) to a first set of the WLSWs connected to the plurality of word lines of a selected memory block during the memory operation.

(119) Turning back to FIG. **12**, the WLSWs are laid out in linear fashion in multiple rows with each WLSW including a peripheral area contact (source S) and two word line contacts (drains D). The two word line contacts D are electrically coupled with the same word line number in different memory blocks, e.g., one word line contact D is electrically connected with WL0 of a first block and the other word line contact D of the same WLSW is electrically connected with WL0 of a second block. Thus, each WLSW includes two switches for the same word line in two different blocks.

(120) As discussed above, the width of each WLSW area (illustrated in FIG. **10**) is dictated largely by three factors: (1) the number of WLSW in the area, (2) the widths W of the switches, and (3) the STI space between the WLSWs. For packaging and space utilization reasons, it is advantageous to minimize the sizes of the WLSW areas so as to ensure that a footprint of a CMOS layer of the chip is not larger than a footprint of an array layer of the chip. In some embodiments, the widths W of some of the WLSWs are reduced by making the maximum programming voltages VPGMmax dependent on the WLSW widths of the associated word lines. In other words, within a memory block, different word lines have different VPGMmax voltages and their WLSWs have different widths W. Thus, rather than all of the WLSWs having identical widths that are optimized for a single VPGMmax that's applied to all of the word lines, only some of the WLSWs have this maximum width and the other WLSWs have lesser widths W to reduce the total size of the WLSW area.

(121) Turning now to FIG. **14**, in an example embodiment, for each word line, VPGMmax is set according to a memory hole cross-sectional shape at that word line. For example, in a three-tiered structure, each NAND string has an upper memory hole, a middle memory hole, and a lower memory hole with the middle memory hole being located between the upper and lower memory holes. Each of these memory holes is generally upside-down cone-shaped and tapers from its top (drain side) to its bottom (source side). Consequently, the word lines that are aligned with the top sections of the memory holes are slower to program due to the larger memory hole cross-sectional area and require a higher VPGMmax than the memory cells that are aligned with the bottom sections, which are faster to program and require a lower VPGMmax.

(122) As discussed above and illustrated in FIG. **13**, as the voltage being passed by a WLSW from the peripheral area to one of the word lines is increased, the voltage V_t that must be applied to the gate to turn on the WLSW increases. Additionally, as the WLSW is made narrower (less wide), the gate voltage required to turn on the WLSW also increases. However, the CMOS has a maximum voltage $V_{wlswmax}$ that can be supplied to the gate. Accordingly, to turn on a WLSW so that it can conduct a very high VPGMmax voltage, the WLSW must be made wide enough to allow no more than the maximum voltage $V_{wlswmax}$ of the CMOS to turn on the WLSW. In other words, the higher the VPGMmax voltage, the wider the WLSW must be made. Conversely, the WLSW can be less wide if the word line coupled to that WLSW has a lower VPGMmax voltage. In some embodiments, the gate voltage VPGMH to turn the WLSWs is constant for all WLSWs in the WLSW area.

(123) The word lines of the memory block are divided up into zones based on which memory holes (the upper memory hole, the middle memory hole, and the lower memory hole) they are aligned

with and where they are located within the respective memory holes, i.e., based on their programming speeds. In the example of FIGS. 14 and 15, the memory block includes two hundred and eighty word lines (WL0-WL279) that are divided into nine zones (Zones 1-9). The nine exemplary zones include a first zone includes WL0-WL14 (aligned with a bottom section of the lower memory hole), a second zone includes WL15-41 (aligned with a middle section of the lower memory hole), a third zone includes WL42-WL51 (aligned with a top section of the lower memory hole), a fourth zone includes WL52-59 (aligned with a bottom section of the middle memory hole), a fifth zone includes WL60-WL80 (aligned with a middle section of the middle memory hole), a sixth zone includes WL81-WL169 (aligned with a top section of the middle memory hole), a seventh zone includes WL170-WL177 (aligned with a bottom section of the upper memory hole), an eighth zone includes WL178-WL199 (aligned with a middle section of the upper memory hole), and a ninth zone WL200-WL279 (aligned with a top section of the upper memory hole). In other embodiments, the word lines could be grouped into more or fewer than nine zones with the word lines of each zone having similar programming speeds. As illustrated in this table, each zone is associated with a unique VPGMmax voltage based on the expected programming speeds. In this example, V1 is the highest VPGMmax voltage that is only applied to the zones with the slowest to program word lines (Zones 6 and 9); V2 is less than V1 and is applied to Zones 2, 5, and 8; V3 is less than V2 and is applied to Zone 3; and V4 is less than V3 and is applied to Zones 1 and 4. V4 is the lowest VPGMmax voltage and is only applied to the zones with the fastest to program word lines. In some embodiments, there could be more or fewer than four unique VPGMmax voltages and they could be applied to the various zones in a different manner than this example.

(124) Turning now to FIG. 16, a plurality of WLSWs having different widths are illustrated. In this example, WLSW 1900 has a width W1, WLSW 1902 has a width W2, WLSW 1904 has a width W3, and WLSW 1906 has a width W4. These widths have a relationship such that $W1 > W2 > W3 > W4$. Although only four are illustrated in this Figure, it should be appreciated that the WLSW area includes one WLSW for each word line in a memory block, e.g., 280 WLSWs for 280 word lines. The widths W of the specific WLSWs depend on which zone the associated word line is located in. For example, with reference to the table of FIG. 15, a WLSW that is electrically coupled with a word line in Zone 9 will have a width W1 to accommodate the large V1 VPGMmax voltage; a WLSW that is electrically coupled with a word line in Zone 3 will have a width W2 to accommodate the V2 VPGMmax voltage; a WLSW that is electrically coupled with a word line in Zone 8 will have a width W3 to accommodate the V3 VPGMmax voltage; and a WLSW that is electrically coupled with a word line in Zone 1 will have a width W4 to accommodate the V4 VPGMmax voltage.

(125) As also illustrated in FIG. 16, in some embodiments, the spacing STI between adjacent WLSWs is variable to further reduce the width of the WLSW area by allowing some of the WLSWs to be more densely packed within the WLSW area. During a programming operation, a programming pulse VPGM is applied to a selected word line and a pass voltage VPASS is applied to the other word lines in a memory block. In an example, the WLSW 1902 is passing the VPGM voltage to the selected word line and the other WLSWs 1900, 1904, 1906 are passing the lesser VPASS voltage to their respective word lines. The spacing STI is determined a function of the difference between VPGMmax and VPASS (VPGMmax—VPASS). More specifically, the spacing STI between adjacent WLSWs across the WLSW area is variable with the gap STI decreasing with decreasing VPGMmax voltages for the word lines that are coupled with the neighboring WLSWs. In other words, two WLSWs that are electrically coupled with word lines that have high VPGMmax voltages are separated from one another by a greater STI than two WLSWs that are electrically coupled with word line that have low VPGMmax voltages. In this example, the gap STI1 is greater than the gap STI2, which is greater than the gap STI3. By using variable spacing between the WLSWs, as opposed to using the same maximum spacing between all WLSWs, the total area of the WLSW area is further reduced to further optimize chip design.

(126) As further illustrated in FIG. 16, the length LG of the gates, which dictates the spacing between the sources and the drains of the WLSWs, may also be determined as a function of the VPGMmax of the word lines coupled to the WLSWs. For example, a gate that is coupled to a WLSW that is coupled with a memory cell that has a high VPGMmax has a length LG that is greater than a gate that is coupled to a WLSW which is coupled with a memory cell that has a low VPGMmax. In the exemplary embodiment, each gate extends through and is connected with two WLSWs. While the WLSWs coupled to the single gate can have different widths W, each gate can only have a single length LG. Thus, the length LG of a gate must be set as a function of the greater VPGMmax of the two word lines coupled to the two WLSWs that share the same gate. By varying the lengths LG of the WLSWs, the WLSW area can be further optimized.

(127) Still further, the space between gate edge and source contact, which is the lightly doped drain region (LDD), may be determined as a function of VPGMmax. Specifically, the length of the LDD areas of a WLSW can be dimensioned based on the VPGMmax voltages of the memory cells attached thereto with a larger VPGMmax voltage being associated with a larger LDD area and vice versa.

(128) In some embodiments, a programming technique is provided to improve programming in memory chips where the WLSWs in a WLSW area have variable widths.

(129) Specifically, as discussed in further detail below, these techniques involve the use of word line specific V_{wlswoV} WLSW overdrive voltages (V_{wlswoV}) to ensure that the gate voltage VPGMH is both high enough to turn on a selected WLSW during programming but lower than a maximum allowable voltage $V_{wlswoMax}$.

(130) During programming, a VPGMH voltage is applied to the gate of a selected WLSW, which is coupled to a selected word line being programmed, to allow the selected WLSW to pass the programming voltage VPGM to the selected word line. The VPGMH voltage is set at a level that is equal to VPGM plus a bias V_{wlswoV} . According to some programming techniques, V_{wlswoV} is set as a function of the threshold voltage V_t of the WLSW (V_{t_WLSW}) and an overdrive voltage (V_{ov}), i.e., $V_{wlswoV} = V_{t_WLSW} + V_{ov}$. Accordingly, $V_{PGMH} = V_{PGM} + V_{t_WLSW} + V_{ov}$. However, as discussed above, reducing the width of a WLSW increases its threshold voltage V_{t_WLSW} . If the same V_{wlswoV} is applied to all WLSWs, then in some cases a narrow WLSW could result in VPGMH exceeding the maximum chip voltage.

(131) In an example embodiment, VPGMH is maintained below the maximum allowable voltage $V_{wlswoMax}$ but high enough to turn on all WLSWs by making the bias V_{wlswoV} word line dependent, i.e., different $V_{wlswoVs}$ for different word lines. For each WLSW, V_{wlswoV} is set as a function of the width W of the WLSW. Since the width W is set as a function of VPGMmax, V_{wlswoV} is also determined as a function of VPGMmax, which is based on the location of a word line within its memory block, i.e., which zone the word line is located in. More specifically, V_{wlswoV} and width W are inversely related, i.e., V_{wlswoV} decreases with increasing width W and vice versa. In the example table of FIG. 18, the WLSWs that are electrically coupled with the word lines in Zones 1, 4, and 7 are associated with V_{wlswoV_1} ; the WLSWs that are electrically coupled with the word lines in Zones 2, 5, and 8 are associated with V_{wlswoV_2} ; the WLSWs that are coupled with the word lines in Zone 3 are associated with V_{wlswoV_3} ; and the WLSWs that are electrically coupled with the word lines in Zones 6 and 9 are associated with V_{wlswoV_4} . These bias voltages are set at levels such that $V_{wlswoV_4} > V_{wlswoV_3} > V_{wlswoV_2} > V_{wlswoV_1}$.

(132) Turning now to FIG. 17, a flow chart is provided that depicts the steps of programming a selected word line WL_n . These steps could be performed by the controller, a processor, a processing device, or any other circuitry that can execute instructions stored in memory.

(133) At step **2000**, programming of the selected word line WL_n begins. At step **2002**, it is determined which of a plurality of zones within the memory block the selected word line WL_n is located in. At step **2004**, the maximum programming voltage VPGMmax is set based on which zone the selected word line WL_n is located in. At step **2006**, the memory cells of the selected word

line WLn are programmed to respective intended data states in a plurality of program loops. Each program loop includes a programming pulse at a programming voltage VPGM and a verify pulse. The programming voltage VPGM increases by a fixed step size dVPGM between program loops. Programming proceeds until either all of the memory cells of the selected word line WLn pass verify or until the programming voltage exceeds VPGMmax, at which point programming fails.

(134) Turning now to FIG. 18, a flow chart is provided that depicts the steps of programming a selected word line WLn. These steps could be performed by the controller, a processor, a processing device, or any other circuitry that can execute instructions stored in memory.

(135) At step **2100**, programming of the selected word line WLn begins. At step **2102**, it is determined which of a plurality of zones within the memory block the selected word line WLn is located in. At step **2104**, a bias voltage Vwlswo, which is a factor in the gate voltage VPGMH applied to the WLSW that is electrically coupled with the selected word line WLn, is set based on which zone the selected word line WLn is located in. At step **2106**, the memory cells of the selected word line WLn are programmed to respective intended data states in a plurality of program loops. Each program loop includes a programming pulse at a programming voltage VPGM and a verify pulse. The programming voltage VPGM increases by a fixed step size dVPGM between program loops. Programming proceeds until either all of the memory cells of the selected word line WLn pass verify or until the programming voltage exceeds VPGMmax, at which point programming fails.

(136) Increasing word line count has been the method implemented for bit growth and cost reduction for each generation of a memory device. One challenge with increasing word line counts is that the proportionally increasing number of word line switches (WLSWs) in the planar CMOS wafer. For example, the number of word lines in an array rapidly increases in the z direction generation after generation, leading to higher and higher bit density for a fixed area. Accordingly, the number of WLSW increases. Since WLSW in the planar CMOS wafer cannot be placed along a z direction as the word lines in the array wafer, the increasing number of WLSW occupies more and more space (specifically, width) of the CMOS wafer. This leads to a situation that the CMOS area becomes larger than the array area. At some point in the future, the cost benefit of increasing word line count will be diminished.

(137) To address this issue, scaling down WLSW accordingly in each generation is the most natural consideration. However, the key factor that prevents the WLSW scaling is the need for a large maximum allowable program voltage (e.g., VPGM MAX) to achieve sufficient Vth window for MLC. To pass the large VPGM MAX, a large WLSW is needed to tolerate the high stress. Unfortunately, unless the memory hole (MH) size can be further scaled, VPGM MAX cannot be scaled from a Vth window perspective.

(138) The WLSW for those word lines with small memory hole critical dimension (CD) (e.g., in the lower portion of each tier) may be scalable because the starting program voltage (e.g., VPGMU) for these WLSW is lower and they never really hit the VPGM MAX. In other words, WLSWs of some lower word lines can be scaled to some extent. However, other WLSWs remain difficult to scale.

(139) To address the issues described, embodiments described herein are directed to reducing VPGM MAX and WLSW (thus chip size) by employing a word line dependent negative bitline (NBL) voltage. More specifically, embodiments described herein enable scaling of WLSWs with word line dependent negative bitline voltage.

(140) To explore this in further detail, FIG. 19 will now be described. FIG. 19 is a schematic view of a two-tiered memory hole. For example, in a two-tiered structure, each memory string has an upper memory hole and a lower memory hole. As depicted in FIG. 19, VPGMU is generally higher on higher word lines of each tier due to the larger memory hole CD. In some embodiments, a global negative bitline voltage may be applied for all word lines. For example, as depicted in FIG. 19, a parameter (e.g., VNBL_global) may be used to control a global negative bitline voltage.

However, because word lines have different VPGM requirements, higher word lines require more negative bitline voltages to make VPGM uniform across all word lines. As such, a parameter, (e.g., VNBL_byWL) may be used to control negative bitline voltages by word line. For example, as depicted in FIG. 19, VNBL_byWL may be applied for higher word lines of the upper and lower tiers.

(141) As described, prior WLSW scaling methods involve only WLSWs for small-VPGMU word lines being scaled. In embodiments described herein, WLSWs for large-VPGMU word lines may also be scaled when VNBL_byWL is applied during programming. Further, additional WLSW scaling may be achieved by applying VNBL_global (e.g., $\sim -3V$).

(142) Turning now to FIG. 20, a flow chart is provided that depicts the steps of programming a selected word line WL_n by word line negative bitline implementation, according to another embodiment of the present disclosure. These steps could be performed by the controller, a processor, a processing device, or any other circuitry that can execute instructions stored in memory.

(143) At step **2002**, programming of the selected word line WL_n begins. At step **2004**, it is determined which of a plurality of zones within the memory block the selected word line, WL_n, is located in. If WL_n is in zone X, at step **2006**, zone X negative bitline voltage is applied (e.g., VNBL_global+VNBL_zonex), and at step **2008**, VPGM for zone X is applied. Thereafter, at step **2010**, program/verify operation continues. Alternatively, if WL_n is in zone Y, at step **2012**, zone Y negative bitline voltage is applied (e.g., VNBL_global+VNBL_zoney), and at step **2014**, VPGM for zone Y is applied. Thereafter, at step **2016**, program/verify operation continues.

(144) One programming technique, known as Quick Pass Write (QPW), slows programming of the memory cells that have passed a verify low VL voltage but have not passed a verify high VH voltage for a given data state (i.e., memory cells which are nearly finished with programming). To slow programming, during the application of a VPGM pulse to the control gate of a selected word line, a QPW voltage is applied to the bit lines coupled to the memory cells that have passed a verify low VL voltage associated with a programmed data state but have not passed the verify high VH voltage associated with that programmed data state. The QPW voltage increases the voltage in the channels containing the memory cells for which slow programming is desired, thereby reducing the voltage difference between the VPGM pulse and the channels and slowing the flow of electrons into the charge trapping materials of certain ones of the memory cells being programmed. Any memory cell with a threshold voltage V_{th} which passes the verify high VH voltage of its intended data state is then locked down, or inhibited, from further programming by applying an inhibit voltage VDDSA to the bit lines coupled to those memory cells during the application of subsequent VPGM pulses to the selected word line.

(145) When implementing QPW, embodiments described herein are implemented only during a program loop for programming a highest data state which is performed without QPW and where VPGM MAX is most crucial. FIG. 21 depicts a flow chart of a conventional program method with QPW (e.g., until F-state has finished programming) until programming of a final program state (e.g., G state) without QPW, according to another embodiment of the present disclosure. These steps could be performed by the controller, a processor, a processing device, or any other circuitry that can execute instructions stored in memory.

(146) At step **2102**, programming of the selected word line WL_n begins. At step **2104**, conventional programming is performed with QPW until F-state finishes, and at step **2106**, G-state programming without QPW starts.

(147) Further, at step **2108**, it is determined which of a plurality of zones within the memory block the selected word line WL_n is located in. If WL_n is in zone X, at step **2110**, zone X negative bitline voltage is applied (e.g., VNBL_global+VNBL_zonex), and at step **2112**, VPGM for zone X is applied. Thereafter, at step **2114**, program/verify operation continues. Alternatively, If WL_n is in zone Y, at step **2116**, zone Y negative bitline voltage is applied (e.g.,

VNBL_global+VNBL_zone)), and at step **2118**, VPGM for zone y is applied. Thereafter, at step **2120**, program/verify operation continues. In some embodiments, VNBL_byWL is also applied to the select gate line SGD and/or the select gate line SGS.

(148) Turning now to FIG. **22**, a flow chart is provided that depicts the steps of programming a selected word line WLn according to one embodiment of the present disclosure. These steps could be performed by the controller, a processor, a processing device, or any other circuitry that can execute instructions stored in memory.

(149) At step **2202**, a selected word line of a plurality of word lines is programmed to respective intended data states in a plurality of program loops. At step **2204**, a bitline corresponding to a memory cell of the selected word line is biased during programming of the selected word line, which comprises providing a negative biasing voltage to the bitline and setting a magnitude of the negative biasing voltage based on a zone of a plurality of zones the selected word line is in. The plurality of word lines are grouped into the plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines.

(150) Various terms are used herein to refer to particular system components. Different companies may refer to a same or similar component by different names and this description does not intend to distinguish between components that differ in name but not in function. To the extent that various functional units described in the following disclosure are referred to as “modules,” such a characterization is intended to not unduly restrict the range of potential implementation mechanisms. For example, a “module” could be implemented as a hardware circuit that includes customized very-large-scale integration (VLSI) circuits or gate arrays, or off-the-shelf semiconductors that include logic chips, transistors, or other discrete components. In a further example, a module may also be implemented in a programmable hardware device such as a field programmable gate array (FPGA), programmable array logic, a programmable logic device, or the like. Furthermore, a module may also, at least in part, be implemented by software executed by various types of processors. For example, a module may comprise a segment of executable code constituting one or more physical or logical blocks of computer instructions that translate into an object, process, or function. Also, it is not required that the executable portions of such a module be physically located together, but rather, may comprise disparate instructions that are stored in different locations and which, when executed together, comprise the identified module and achieve the stated purpose of that module. The executable code may comprise just a single instruction or a set of multiple instructions, as well as be distributed over different code segments, or among different programs, or across several memory devices, etc. In a software, or partial software, module implementation, the software portions may be stored on one or more computer-readable and/or executable storage media that include, but are not limited to, an electronic, magnetic, optical, electromagnetic, infrared, or semiconductor-based system, apparatus, or device, or any suitable combination thereof. In general, for purposes of the present disclosure, a computer-readable and/or executable storage medium may be comprised of any tangible and/or non-transitory medium that is capable of containing and/or storing a program for use by or in connection with an instruction execution system, apparatus, processor, or device.

(151) Similarly, for the purposes of the present disclosure, the term “component” may be comprised of any tangible, physical, and non-transitory device. For example, a component may be in the form of a hardware logic circuit that is comprised of customized VLSI circuits, gate arrays, or other integrated circuits, or is comprised of off-the-shelf semiconductors that include logic chips, transistors, or other discrete components, or any other suitable mechanical and/or electronic devices. In addition, a component could also be implemented in programmable hardware devices such as field programmable gate arrays (FPGA), programmable array logic, programmable logic devices, etc. Furthermore, a component may be comprised of one or more silicon-based integrated circuit devices, such as chips, die, die planes, and packages, or other discrete electrical devices, in an electrical communication configuration with one or more other components via electrical

conductors of, for example, a printed circuit board (PCB) or the like. Accordingly, a module, as defined above, may in certain embodiments, be embodied by or implemented as a component and, in some instances, the terms module and component may be used interchangeably.

(152) Where the term “circuit” is used herein, it includes one or more electrical and/or electronic components that constitute one or more conductive pathways that allow for electrical current to flow. A circuit may be in the form of a closed-loop configuration or an open-loop configuration. In a closed-loop configuration, the circuit components may provide a return pathway for the electrical current. By contrast, in an open-looped configuration, the circuit components therein may still be regarded as forming a circuit despite not including a return pathway for the electrical current. For example, an integrated circuit is referred to as a circuit irrespective of whether the integrated circuit is coupled to ground (as a return pathway for the electrical current) or not. In certain exemplary embodiments, a circuit may comprise a set of integrated circuits, a sole integrated circuit, or a portion of an integrated circuit. For example, a circuit may include customized VLSI circuits, gate arrays, logic circuits, and/or other forms of integrated circuits, as well as may include off-the-shelf semiconductors such as logic chips, transistors, or other discrete devices. In a further example, a circuit may comprise one or more silicon-based integrated circuit devices, such as chips, die, die planes, and packages, or other discrete electrical devices, in an electrical communication configuration with one or more other components via electrical conductors of, for example, a printed circuit board (PCB). A circuit could also be implemented as a synthesized circuit with respect to a programmable hardware device such as a field programmable gate array (FPGA), programmable array logic, and/or programmable logic devices, etc. In other exemplary embodiments, a circuit may comprise a network of non-integrated electrical and/or electronic components (with or without integrated circuit devices). Accordingly, a module, as defined above, may in certain embodiments, be embodied by or implemented as a circuit.

(153) It will be appreciated that example embodiments that are disclosed herein may be comprised of one or more microprocessors and particular stored computer program instructions that control the one or more microprocessors to implement, in conjunction with certain non-processor circuits and other elements, some, most, or all of the functions disclosed herein. Alternatively, some or all functions could be implemented by a state machine that has no stored program instructions, or in one or more application-specific integrated circuits (ASICs) or field-programmable gate arrays (FPGAs), in which each function or some combinations of certain of the functions are implemented as custom logic. A combination of these approaches may also be used. Further, references below to a “controller” shall be defined as comprising individual circuit components, an application-specific integrated circuit (ASIC), a microcontroller with controlling software, a digital signal processor (DSP), a field programmable gate array (FPGA), and/or a processor with controlling software, or combinations thereof.

(154) Additionally, the terms “couple,” “coupled,” or “couples,” where may be used herein, are intended to mean either a direct or an indirect connection. Thus, if a first device couples, or is coupled to, a second device, that connection may be by way of a direct connection or through an indirect connection via other devices (or components) and connections.

(155) Regarding, the use herein of terms such as “an embodiment,” “one embodiment,” an “exemplary embodiment,” a “particular embodiment,” or other similar terminology, these terms are intended to indicate that a specific feature, structure, function, operation, or characteristic described in connection with the embodiment is found in at least one embodiment of the present disclosure. Therefore, the appearances of phrases such as “in one embodiment,” “in an embodiment,” “in an exemplary embodiment,” etc., may, but do not necessarily, all refer to the same embodiment, but rather, mean “one or more but not all embodiments” unless expressly specified otherwise. Further, the terms “comprising,” “having,” “including,” and variations thereof, are used in an open-ended manner and, therefore, should be interpreted to mean “including, but not limited to . . .” unless expressly specified otherwise. Also, an element that is preceded by “comprises . . . a” does not,

without more constraints, preclude the existence of additional identical elements in the subject process, method, system, article, or apparatus that includes the element.

(156) The terms “a,” “an,” and “the” also refer to “one or more” unless expressly specified otherwise. In addition, the phrase “at least one of A and B” as may be used herein and/or in the following claims, whereby A and B are variables indicating a particular object or attribute, indicates a choice of A or B, or both A and B, similar to the phrase “and/or.” Where more than two variables are present in such a phrase, this phrase is hereby defined as including only one of the variables, any one of the variables, any combination (or sub-combination) of any of the variables, and all of the variables.

(157) Further, where used herein, the term “about” or “approximately” applies to all numeric values, whether or not explicitly indicated. These terms generally refer to a range of numeric values that one of skill in the art would consider equivalent to the recited values (e.g., having the same function or result). In certain instances, these terms may include numeric values that are rounded to the nearest significant figure.

(158) In addition, any enumerated listing of items that is set forth herein does not imply that any or all of the items listed are mutually exclusive and/or mutually inclusive of one another, unless expressly specified otherwise. Further, the term “set,” as used herein, shall be interpreted to mean “one or more,” and in the case of “sets,” shall be interpreted to mean multiples of (or a plurality of) “one or more,” “ones or more,” and/or “ones or mores” according to set theory, unless expressly specified otherwise.

(159) The foregoing detailed description has been presented for purposes of illustration and description. It is not intended to be exhaustive or be limited to the precise form disclosed. Many modifications and variations are possible in light of the above description. The described embodiments were chosen to best explain the principles of the technology and its practical application to thereby enable others skilled in the art to best utilize the technology in various embodiments and with various modifications as are suited to the particular use contemplated. The scope of the technology is defined by the claims appended hereto.

Claims

1. A memory device, comprising: a memory block that includes a plurality of memory cells that are arranged in a plurality of word lines; a plurality of word line switch transistors that are electrically coupled with the plurality of word lines, wherein the plurality of word lines are grouped into a plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines; programming circuitry being configured to program a selected word line of the plurality of word lines to respective intended data states in a plurality of program loops; and a bitline biasing circuit for biasing a bitline corresponding to a memory cell of the selected word line during programming of the selected word line, the bitline biasing circuit operating to provide a negative biasing voltage to the bitline, wherein the bitline biasing circuit is configured to set a magnitude of the negative biasing voltage based on which zone of the plurality of zones the selected word line is in.
2. The memory device as set forth in claim 1, wherein the bitline biasing circuit is further configured to provide a same negative biasing voltage for any zone of the plurality of zones.
3. The memory device as set forth in claim 1, wherein word line switch transistors of at least one zone of the plurality of zones have different widths than word line switch transistors of at least one other zone of the plurality of zones.
4. The memory device as set forth in claim 1, wherein the bitline biasing circuit is further configured to provide the negative biasing voltage only during a program loop of the plurality of loops for programming a highest data state.
5. The memory device as set forth in claim 1, wherein some word line switch transistors have a first

width and some other word line switch transistors have a second width that is different than the first width.

6. The memory device as set forth in claim 1, wherein the magnitude of the negative biasing voltage is higher for a zone of the plurality of zones associated with a top section of a memory hole than other zones of the plurality of zones associated with other sections of the memory hole.
7. The memory device as set forth in claim 1, wherein the magnitude of the negative biasing voltage is lower for a zone of the plurality of zones associated with a bottom section of a memory hole than other zones of the plurality of zones associated with other sections of the memory hole.
8. A method of operating a memory device, comprising the steps of: programming a selected word line of a plurality of word lines to respective intended data states in a plurality of program loops; and biasing a bitline corresponding to a memory cell of the selected word line during programming of the selected word line comprising providing a negative biasing voltage to the bitline and setting a magnitude of the negative biasing voltage based on a zone of a plurality of zones the selected word line is in, wherein the plurality of word lines are grouped into the plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines.
9. The method as set forth in claim 8, further comprising: providing a same negative biasing voltage for any zone of the plurality of zones.
10. The method as set forth in claim 8, wherein word line switch transistors of at least one zone of the plurality of zones have different widths than word line switch transistors of at least one other zone of the plurality of zones.
11. The method as set forth in claim 8, further comprising: providing the negative biasing voltage only during a program loop of the plurality of loops for programming a highest data state.
12. The method as set forth in claim 8, wherein a plurality of word line switch transistors are electrically coupled with the plurality of word lines and some word line switch transistors have a first width and some other word line switch transistors have a second width that is different than the first width.
13. The method as set forth in claim 8, wherein the magnitude of the negative biasing voltage is higher for a zone of the plurality of zones associated with a top section of a memory hole than other zones of the plurality of zones associated with other sections of the memory hole.
14. The method as set forth in claim 8, wherein the magnitude of the negative biasing voltage is lower for a zone of the plurality of zones associated with a bottom section of a memory hole than other zones of the plurality of zones associated with other sections of the memory hole.
15. An apparatus, comprising: a means for programming a selected word line of a plurality of word lines to respective intended data states in a plurality of program loops; a means for providing a negative biasing voltage to a bitline corresponding to a memory cell of the selected word line during programming of the selected word line; and a means for setting a magnitude of the negative biasing voltage based on a zone of a plurality of zones the selected word line is in, wherein the plurality of word lines are grouped into the plurality of zones based on a size of a word line switch transistor associated with each word line of the plurality of word lines.
16. The apparatus as set forth in claim 15, further comprising: a means for providing a same negative biasing voltage for any zone of the plurality of zones.
17. The apparatus as set forth in claim 15, further comprising: a means for providing the negative biasing voltage only during a program loop of the plurality of loops for programming a highest data state.
18. The apparatus as set forth in claim 15, wherein a plurality of word line switch transistors are electrically coupled with the plurality of word lines and some word line switch transistors have a first width and some other word line switch transistors have a second width that is different than the first width.
19. The apparatus as set forth in claim 15, wherein the magnitude of the negative biasing voltage is higher for a zone of the plurality of zones associated with a top section of a memory hole than other

zones of the plurality of zones associated with other sections of the memory hole.

20. The apparatus as set forth in claim 15, wherein the magnitude of the negative biasing voltage is lower for a zone of the plurality of zones associated with a bottom section of a memory hole than other zones of the plurality of zones associated with other sections of the memory hole.
